



*IPW*  
*AF*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

PATENT APPLICATION

Inventor: Jeffrey W. Carr

Appln. No.: 10/002,483

Confirm. No.: 2209

Filed: November 1, 2001

Title: METHOD FOR ATMOSPHERIC PRESSURE REACTIVE  
ATOM PLASMA PROCESSING FOR SURFACE  
MODIFICATION

Art Unit: 1763

Examiner: Allan W. Olsen

Customer No. 23910

**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8**

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to **Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450**, on the date shown below.

*Mathew Otts*

(Signature)

Mathew Otts

Signature Date: 2/11/2005

**RESPONSE B TO OFFICE ACTION UNDER 37 C.F.R. §1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This RESPONSE C is in reply to the final Office Action dated January 12, 2005. No fee is believed due.

**Amendments**

Please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of the claims which begins on

Page 2 of this paper.

**Remarks** begin on Page 12 of this paper.